

Photocathode-driven injector linac design for ~~Korea-4GSR~~ KLS

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Photon sources in Korea



KLS (2021~2029)

4 GeV, 800 m

S-band photocathode + 200 MeV linac

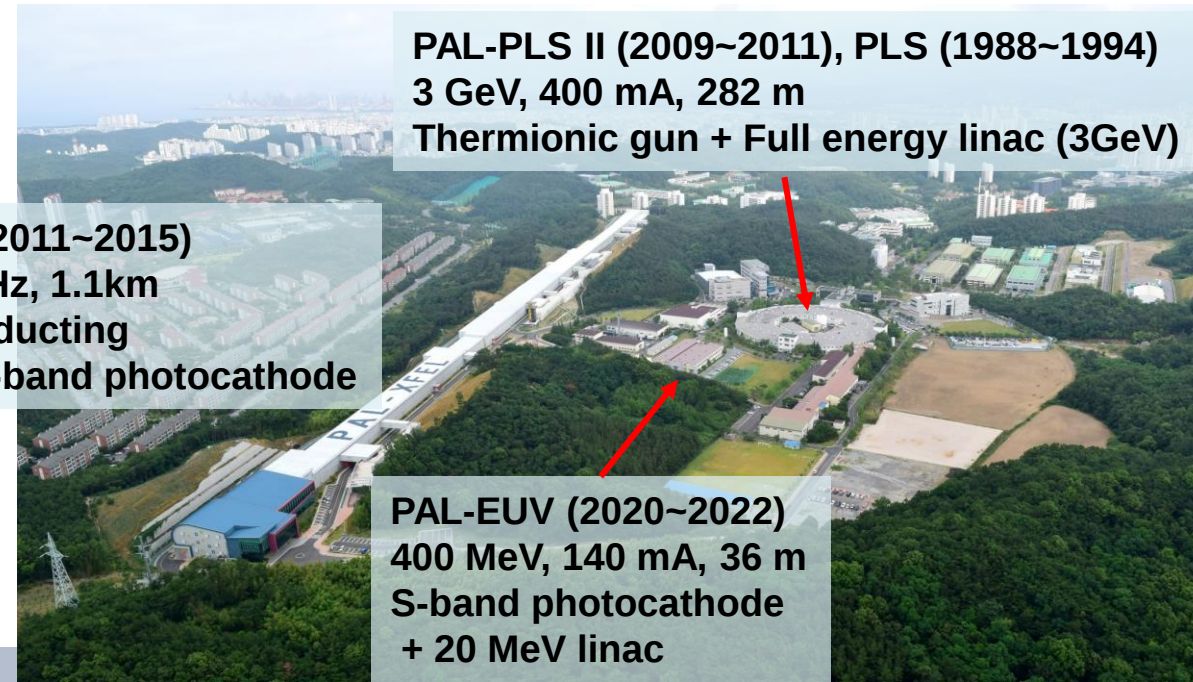


Parameter	Units	PLS-II	KLS
Electron energy	GeV	3	4
Horiz. Emittance	pm	5800	58 (RB: 39)
Vert. Emittance	pm	~ 58	~ 5.8 (RB: 39)
Bunch length (rms)	ps	20	13 (50 with HC)
Circumference	m	280	800
Harmonic #		470	1332

PAL-PLS II (2009~2011), PLS (1988~1994)

3 GeV, 400 mA, 282 m

Thermionic gun + Full energy linac (3GeV)



PAL-XFEL (2011~2015)

10 GeV, 60 Hz, 1.1km

Normal conducting

Based on S-band photocathode

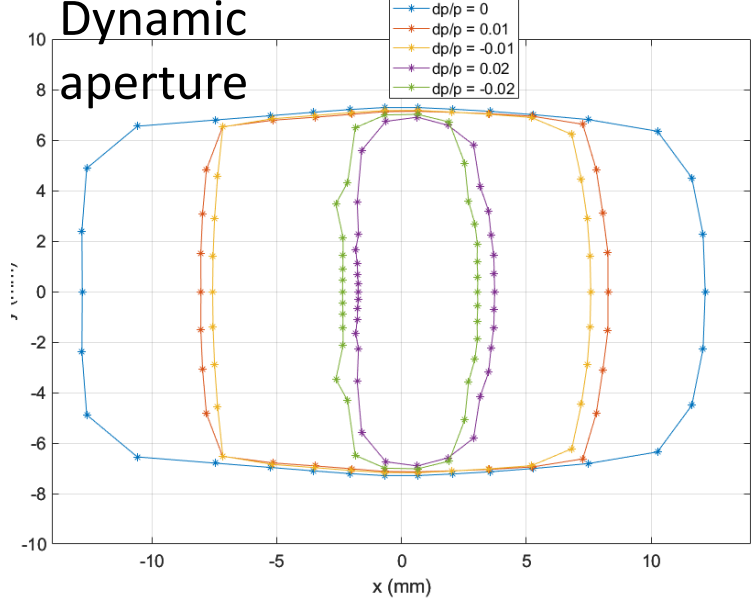
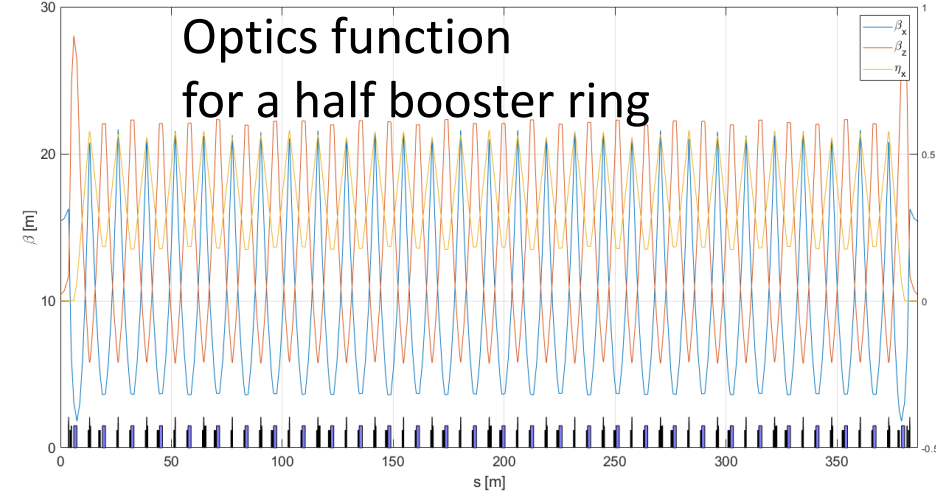
PAL-EUV (2020~2022)

400 MeV, 140 mA, 36 m

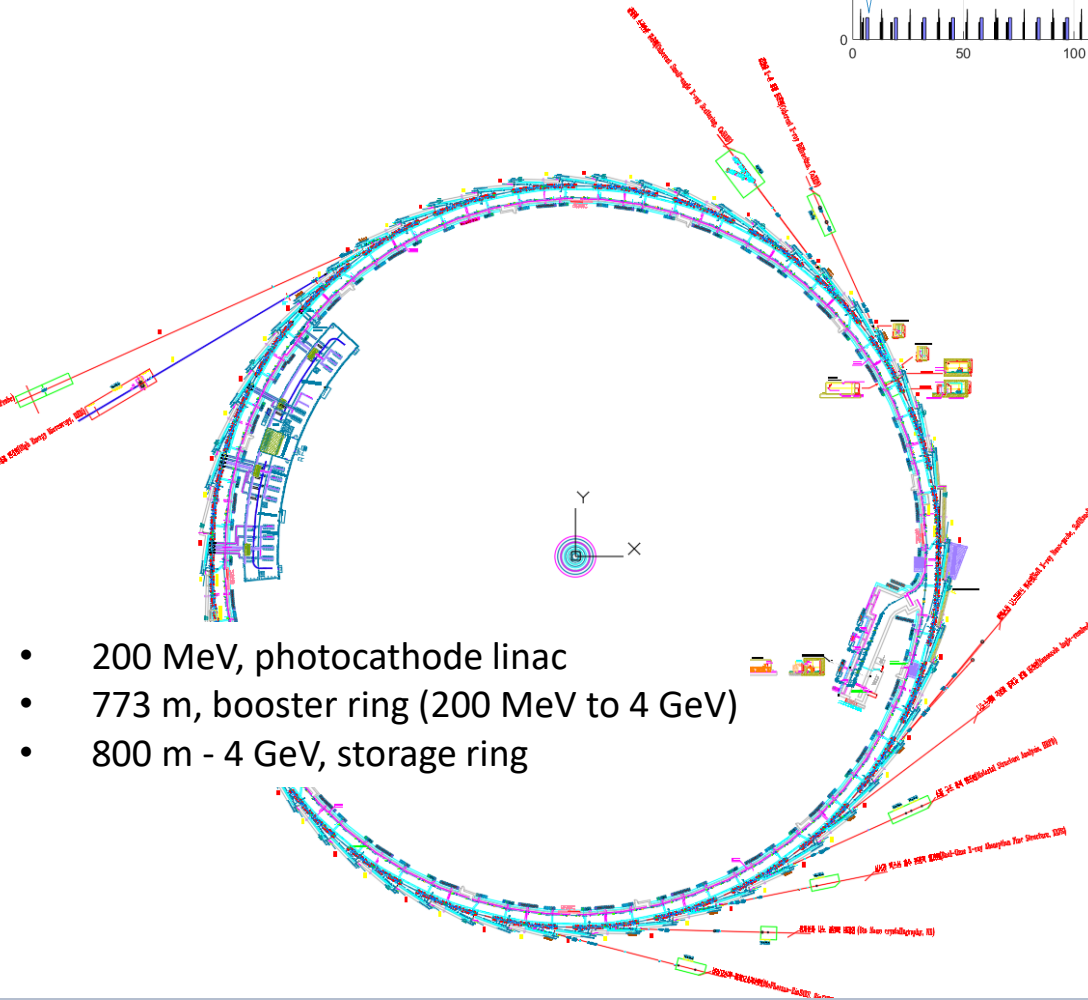
S-band photocathode

+ 20 MeV linac

KLS LINAC requirements



Energy range for 100% injection, $\pm 1.5 \%$

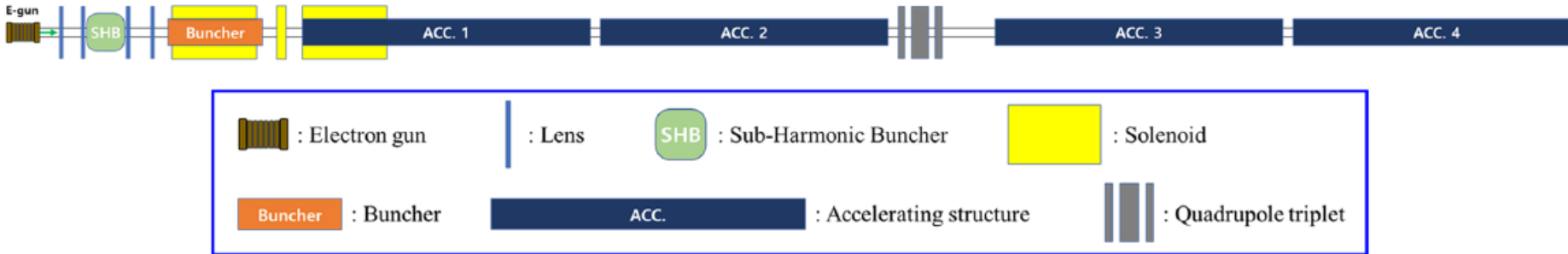


	Multi-bunch	Single-bunch
Energy	200 MeV	200 MeV
Frequency	2997.56 ± 0.1 MHz	2997.56 ± 0.1 MHz
Emittance (at 200 MeV)	≤ 10 nm	≤ 10 nm
Relative energy spread (rms)	$\leq 0.3 \%$	$\leq 0.3 \%$
Pulse to Pulse energy jitter(rms)	$\leq 0.2 \%$	$\leq 0.2 \%$
Bunch charge (charge stability)	1 to 3 nC (5%)	0.01 to 1 nC (2%)
Pulse duration	128 ns (64 bunches)	6-8 ps FWHM
Repetition rate	2 Hz	2 Hz (60 Hz)

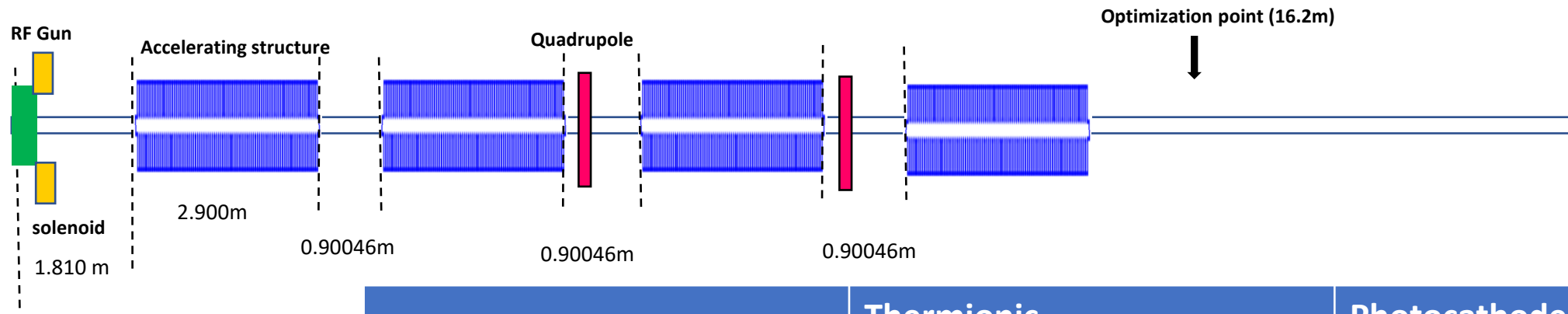
Thermionic vs. photocathode gun, 1 nC

- Thermionic (e.g. SIRIUS in Brazil)

: Initial beam Twiss parameters obtained from CST simulations, used as input for the PARMELA simulation

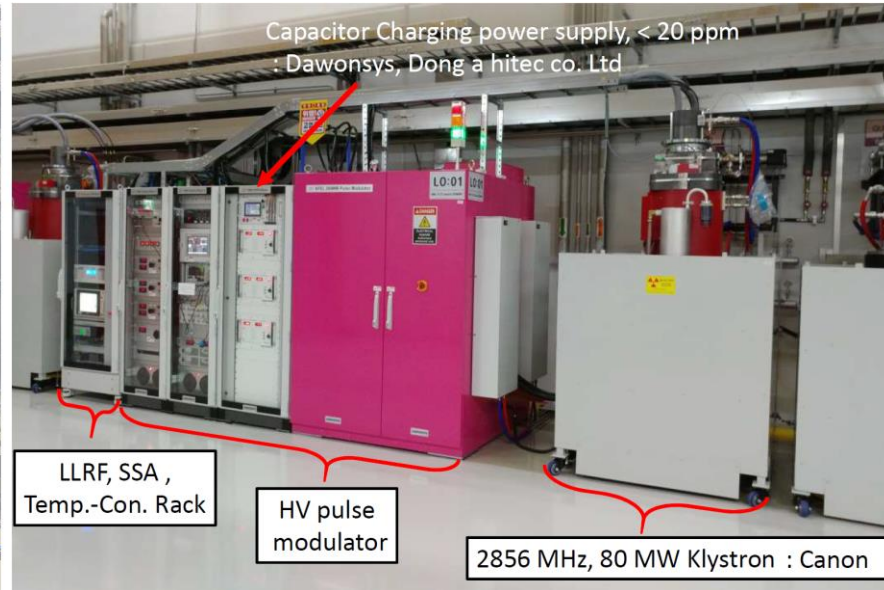
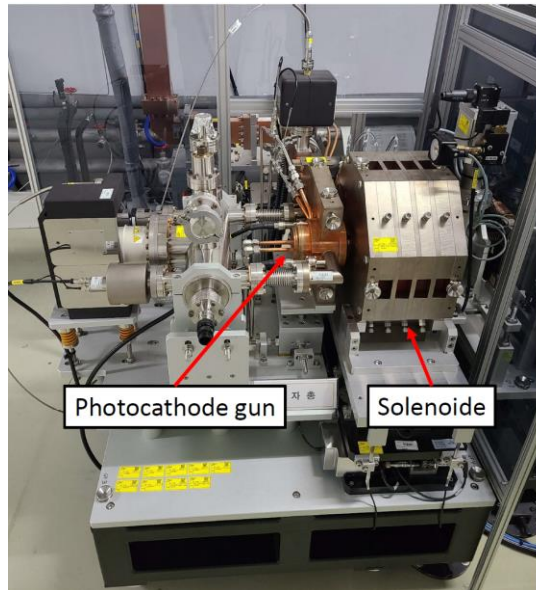
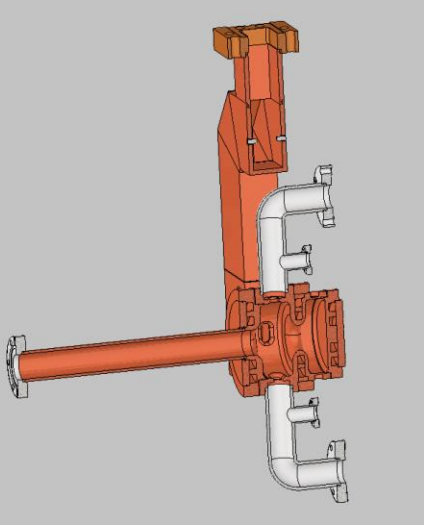


- Photocathode : ASTRA simulation



	Thermionic	Photocathode
Emittance X (nm-rad)	130 (norm. 54 mm-mrad)	8.4 (norm. 3.3 mm-mrad)
Emittance Y (nm-rad)	150 (norm. 62 mm-mrad)	8.2 (norm. 3.2 mm-mrad)
Energy spread at 200 MeV	0.3%	0.2%

S-band photocathode based LINAC experiences at PAL



- ❖ Matured technology in PAL : S-band photocathode
 - 10 years R&D + 10 years operation experience
 - 6 MeV, 250 pC, 60 Hz routine operation since 2016
- ❖ Best stability at gun : energy and time
 - CCPS + PFN + sagnoc based sync. + 0.01° LCW stability
- +saturation operation at Klystron provides
 - ~ Phase stability 0.01 (~10fs), RF power stability 10^{-4}
- ❖ Stable Injector operation
 - e- beam energy stability : 5×10^{-5}
 - beam based feedback provides phase space conservation

KLS LINAC vs PAL-XFEL

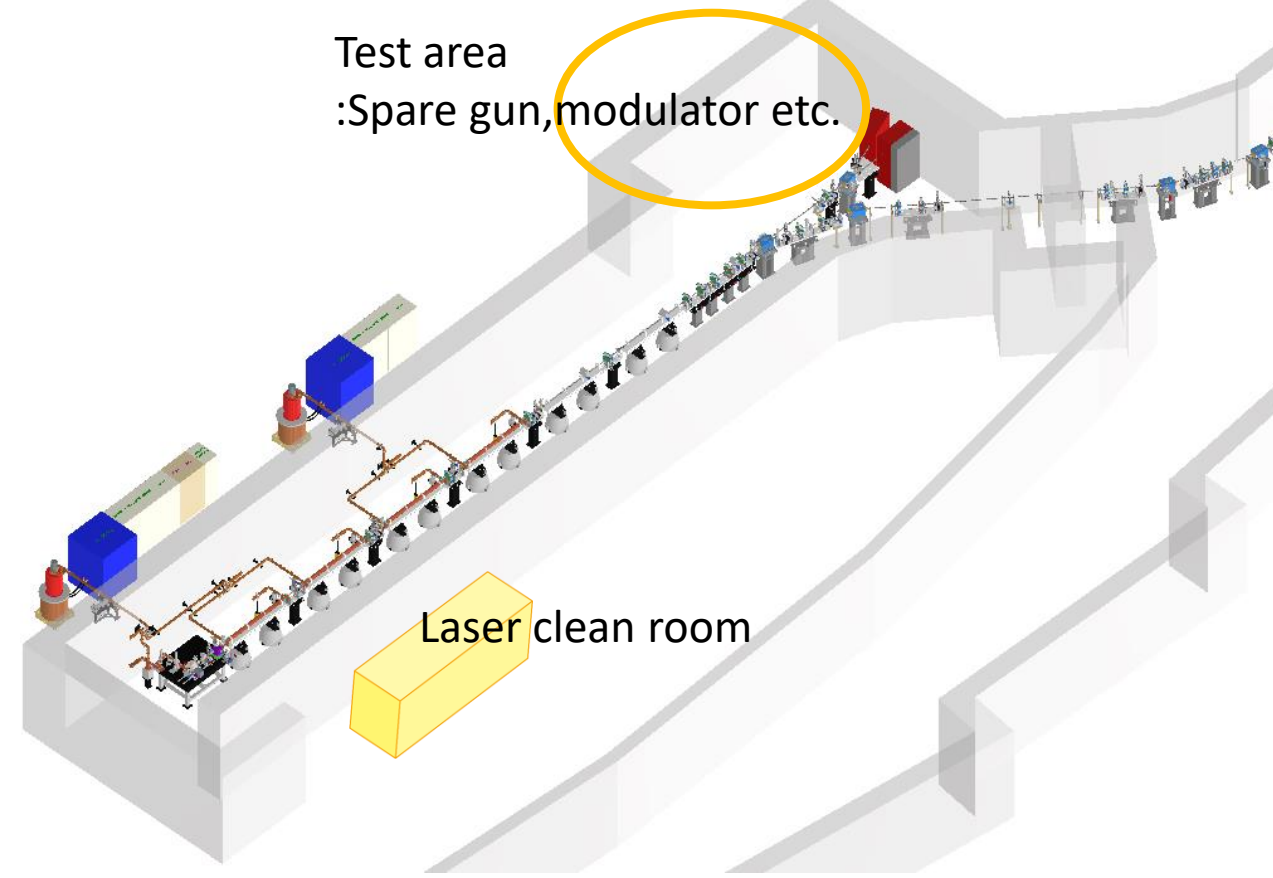
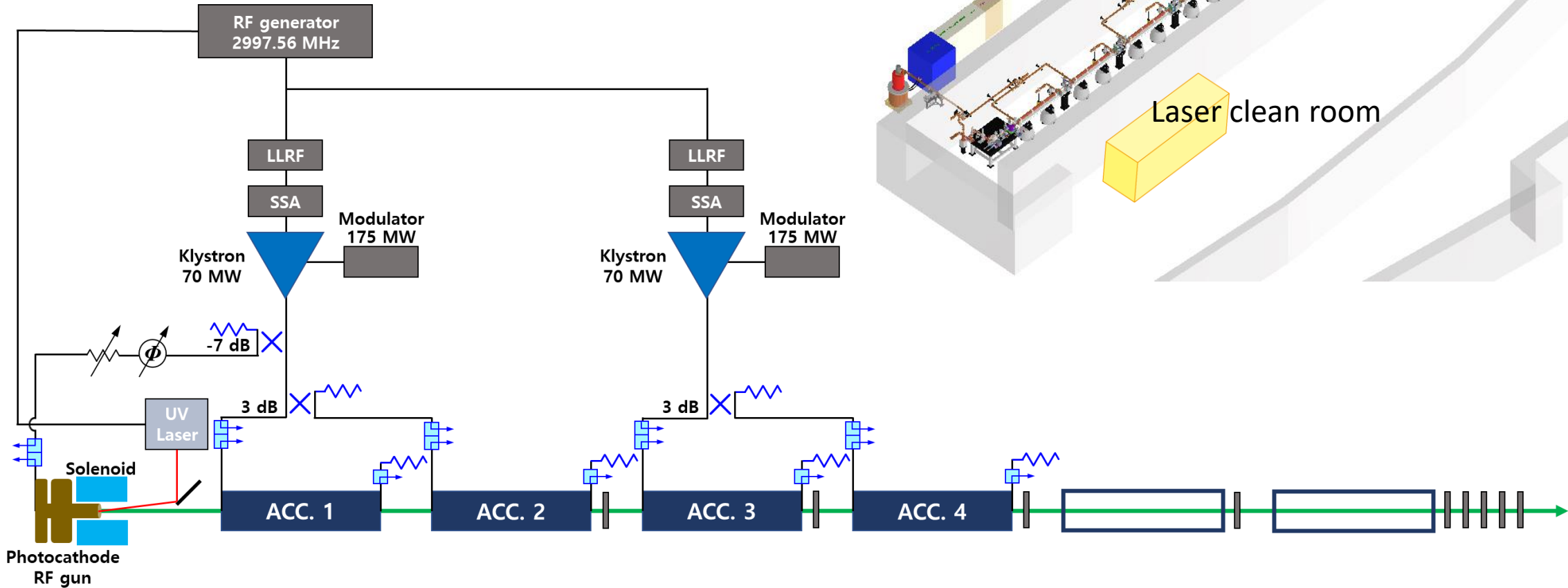
	KLS LINAC	PAL-XFEL
RF frequency	2997.56 $\pm$ 0.1 MHz, variable	2856 MHz fixed
Trigger timing	Depending on booster injection timing	fixed
Bunch charge	Multi, 1 to 3 nC Single, 0.01 to 1 nC	250 pC fixed
Pulse duration (number of bunch)	128 ns (64 bunches) 6~7 ps (single bunch)	3 ps FWHM (single bunch)
Repetition rate	2 Hz	$\leq$ 60 Hz Single bunch (two bunch in the future)

LCW parameters

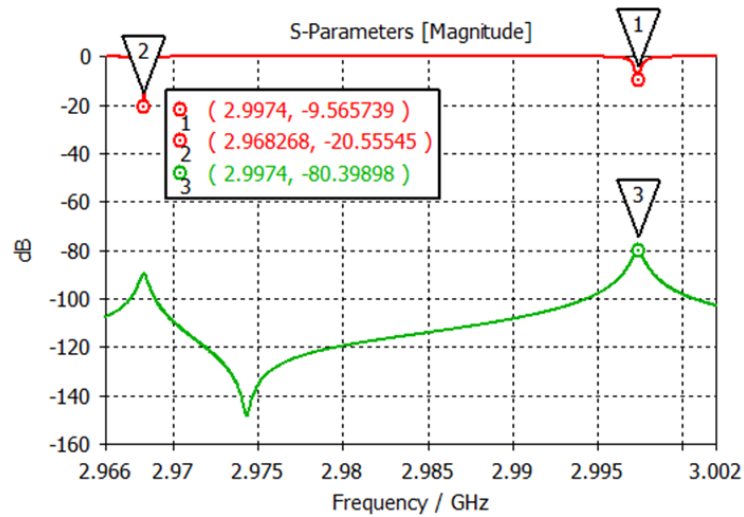
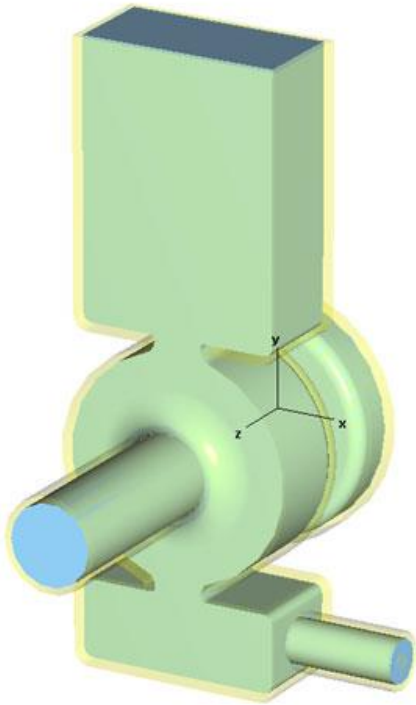
- Acceleration tube : 25 ~ 30 °C (copper 50 KHz/ °C)
- Photocathode gun : 25 ~ 50 °C

Timing Synchronization System

- Pseudo Sync. operation (in the same way as SACLA)
→ synchronous operation



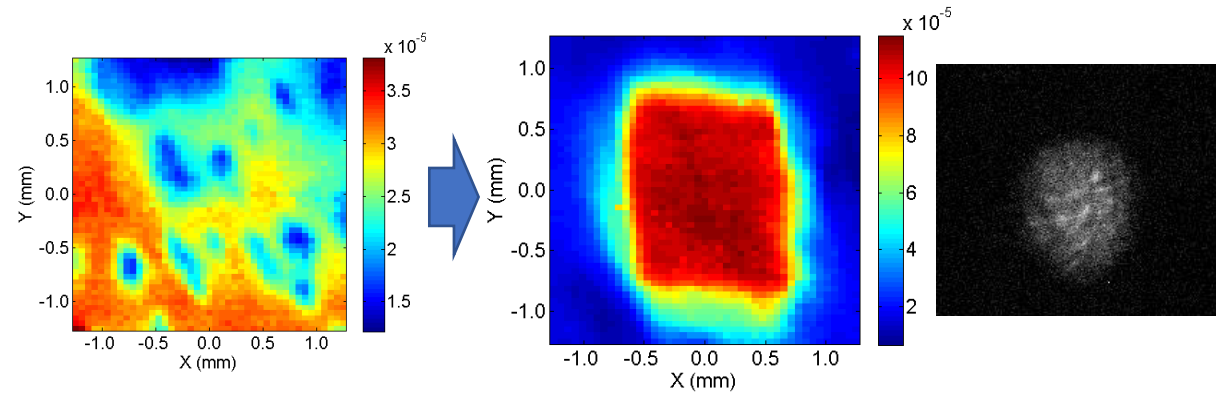
1.5 cell photocathode (quasi-coupler)



- 2-port cavity composed of a full cell and a half cell
- Coupling coefficient: $\beta = 2.00$; Field balance (FB): 1.00
- π -mode frequency: $f_{\pi} = 2997.40$ MHz, $\Delta f = 29.1$ MHz

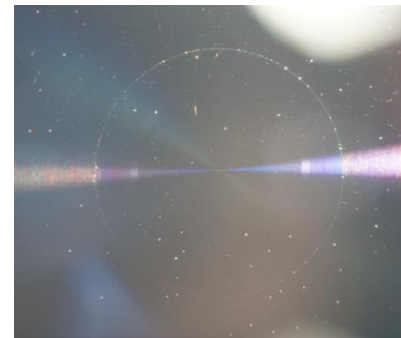
- Laser cleaning

: Low surface damage using ~ 300 ps long IR laser cleaning



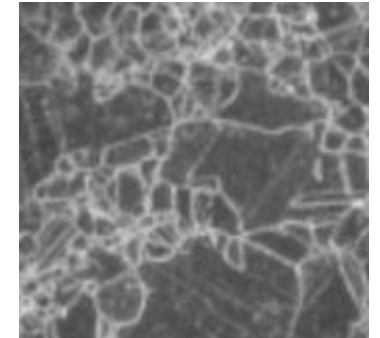
- Implementing single Cu crystal

Single crystal brazing



10mm

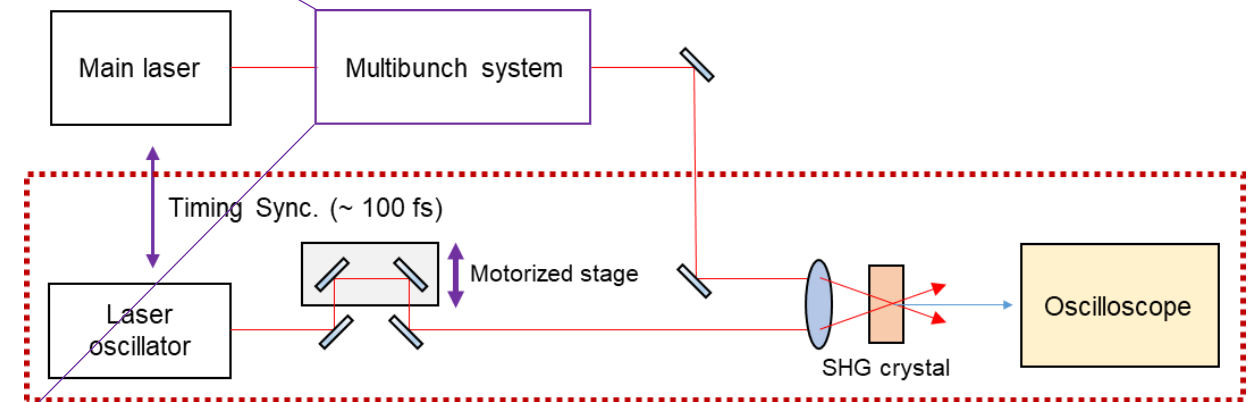
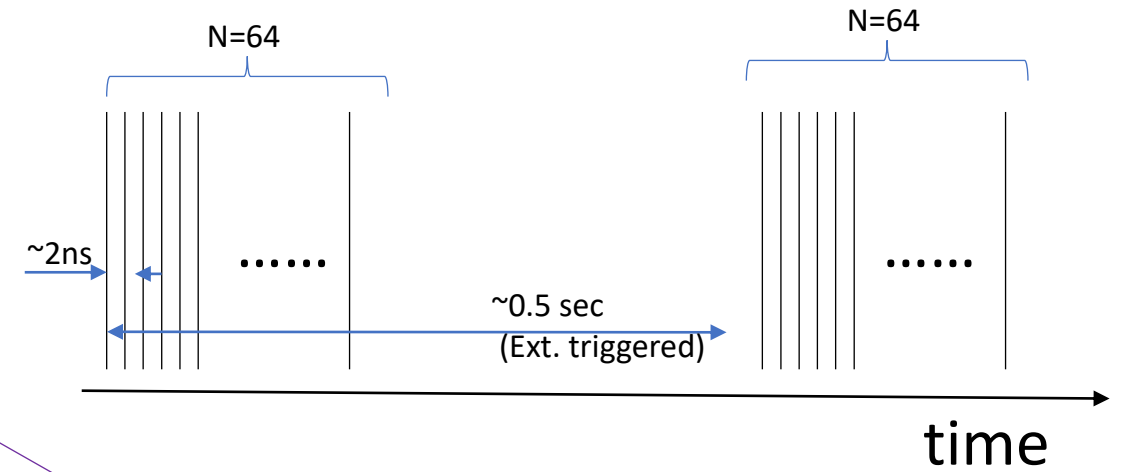
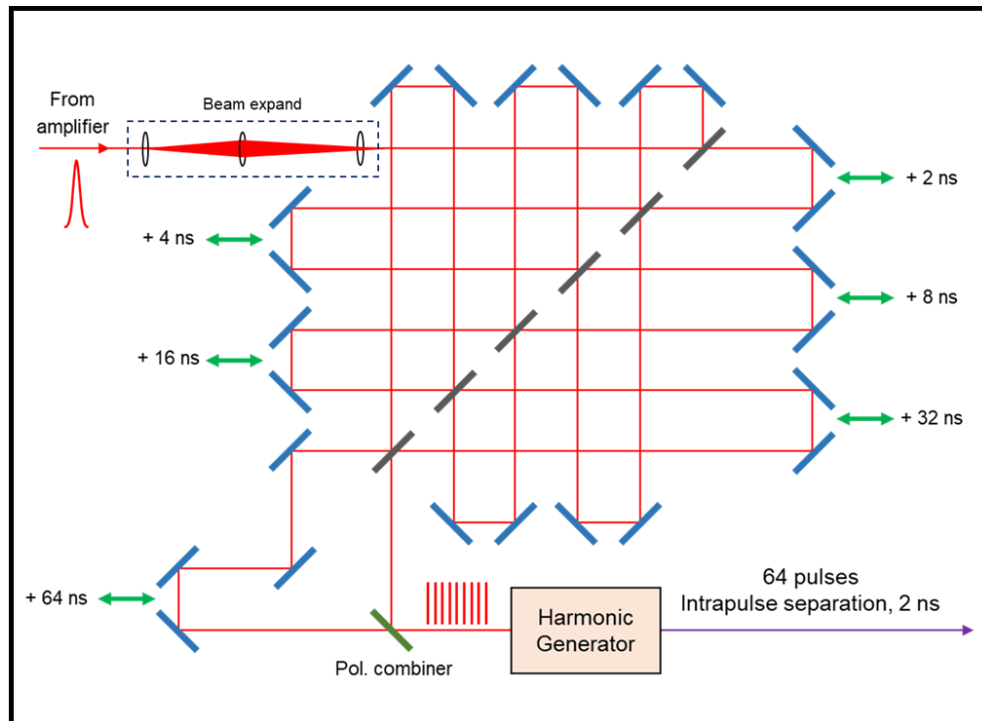
OFHC

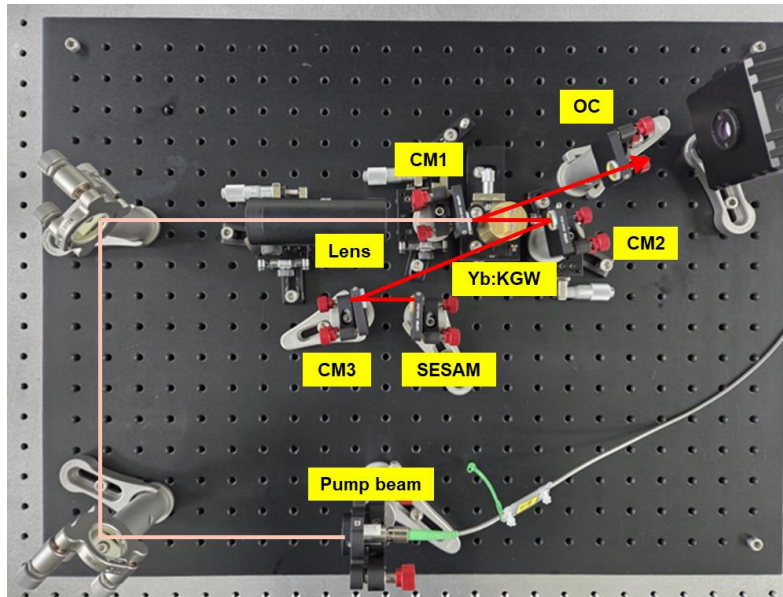
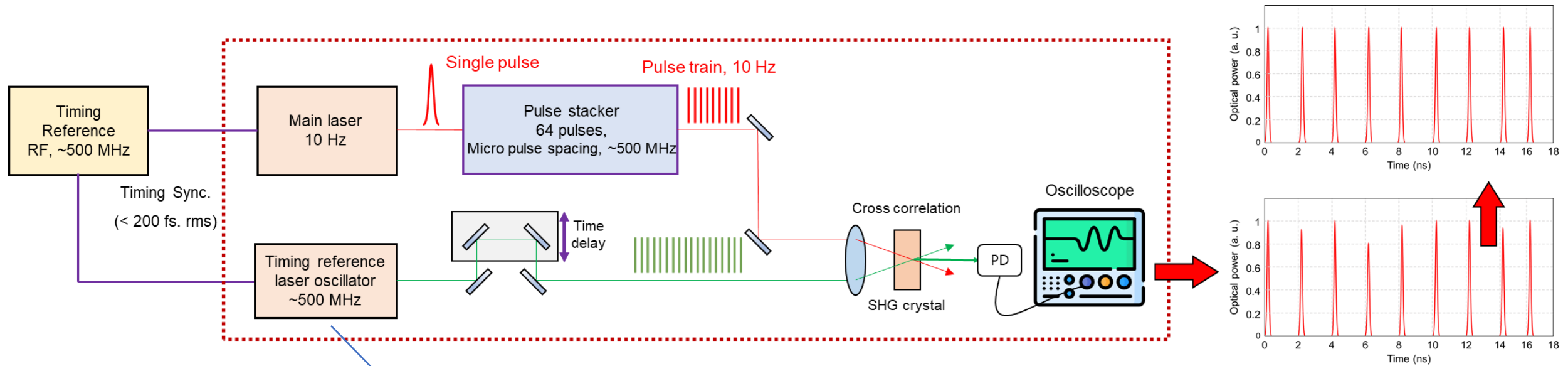


1 mm

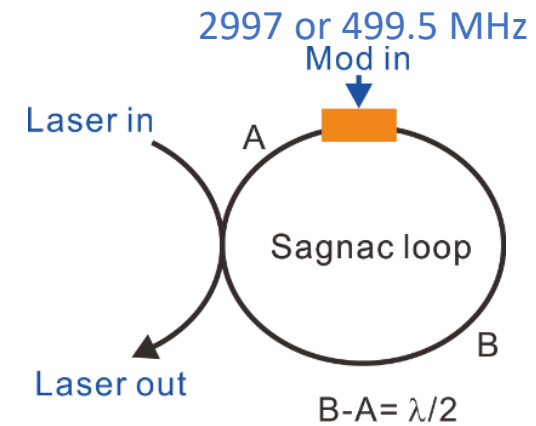
Laser System

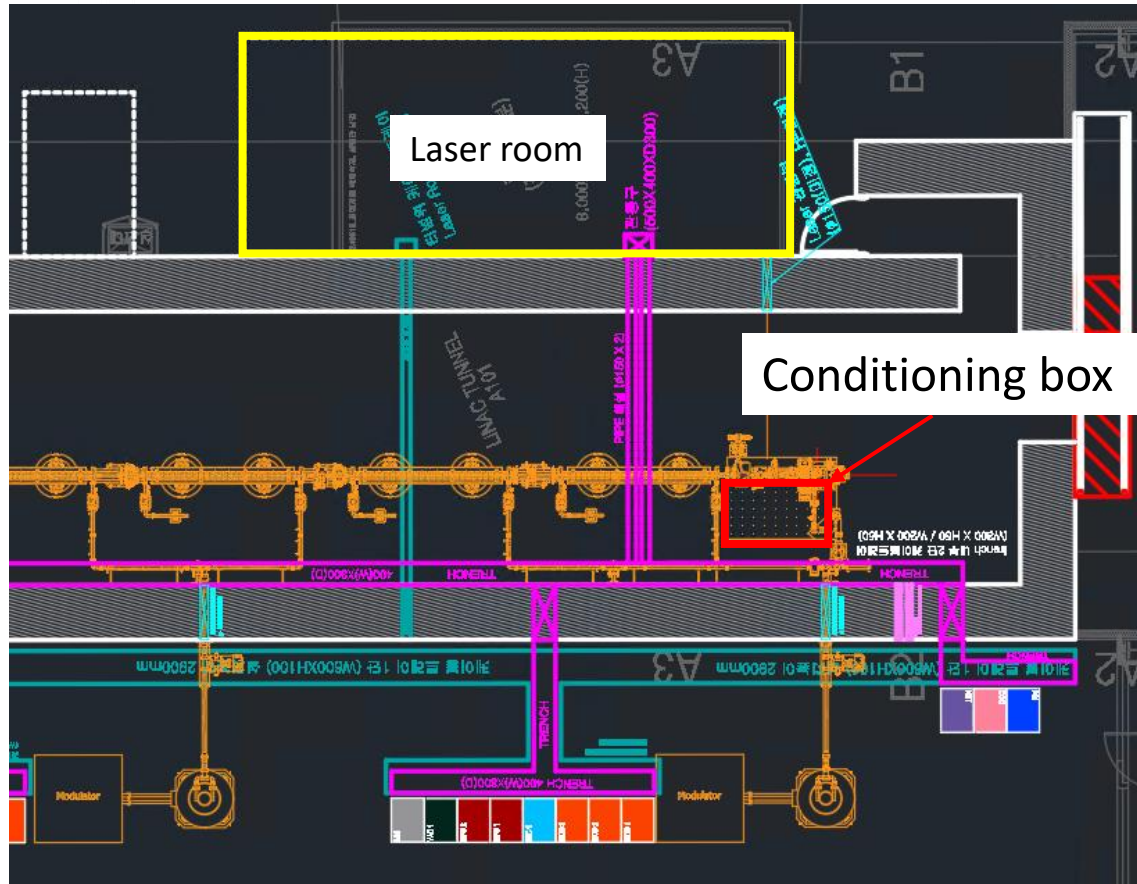
- Yb laser, **Regen**(~1030 nm), 5 mJ, 4th harmonic for UV
- Single/Burst mode convert
 - Convert time (<1 min)**



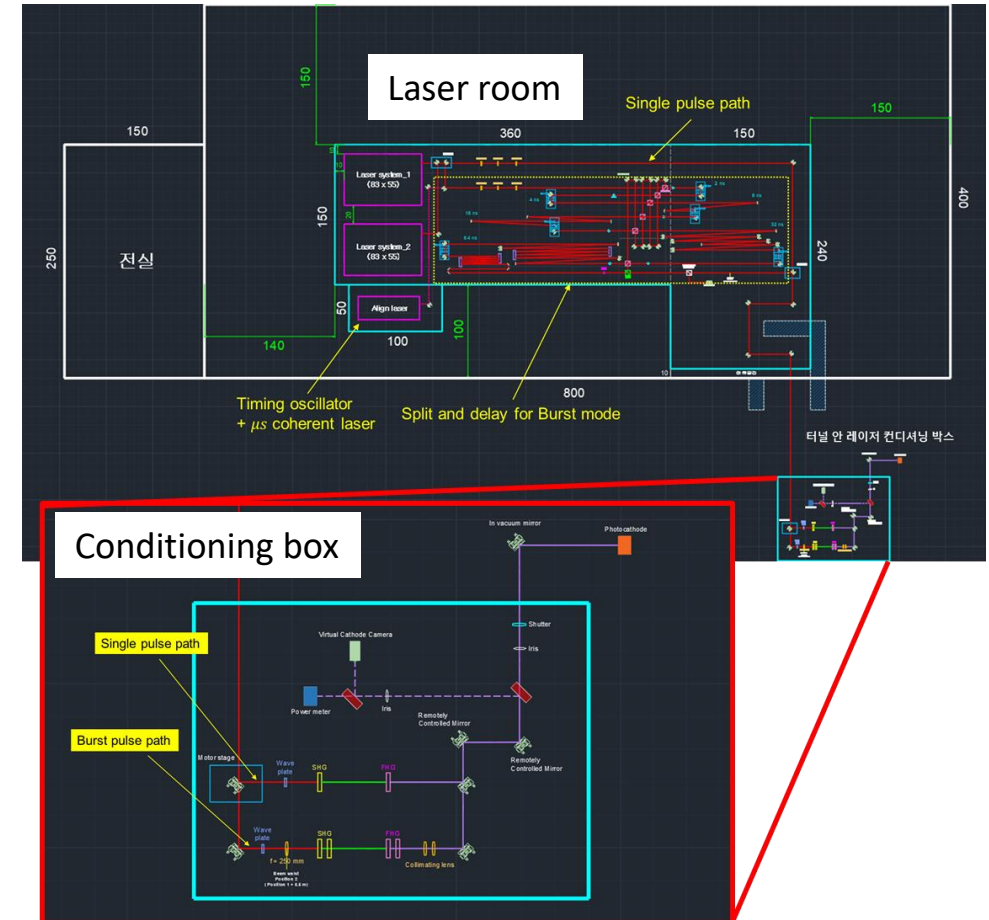


- Home built laser synchronization < 30 fs rms



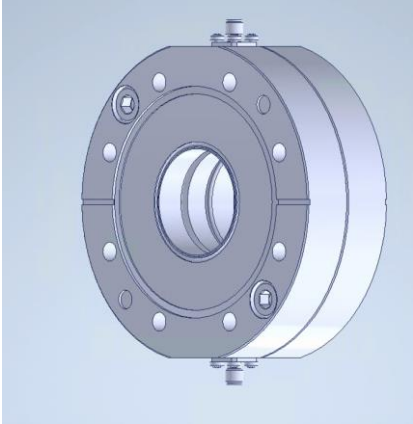


Poster : TUPO068 by Namseok Go
Design for a Femtosecond-Synchronized Nanosecond
Laser Pulse Train System for the Korea-4GSR



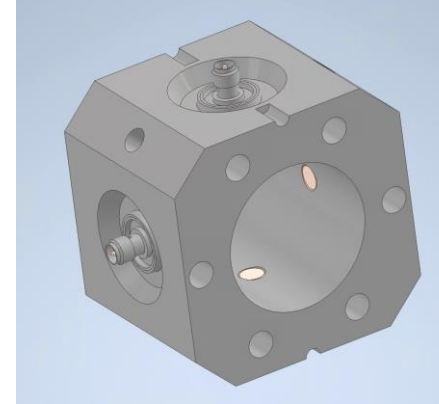
LINAC Beam Diagnostic Devices

Integrating Current Monitor



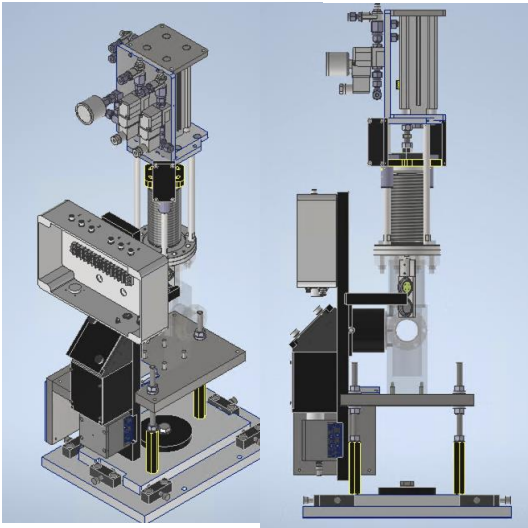
- Beam pulse charge measurement
 - 64 bunches/pulse
 - Beam Transmission
- Bergoz, ICT
- Resolution: 2 pC

Beam Position Monitor



- Pickup: 6 mm diameter
- Electronics: Libera Single Pass E
- Resolution: 1 μm at 1 nC
- Bunch-by-bunch measurement at BAS

Beam Profile Monitor (Screen)



- Dual YAG, OTR screens
 - YAG for low charge
 - OTR for high charge and precise measurement
- Resolution: estimated from Simulation
 - Position: 20 μm at 10 pC
 - Size: 5% at 10 pC
- Emittance & Twiss parameters
- Energy & energy spread

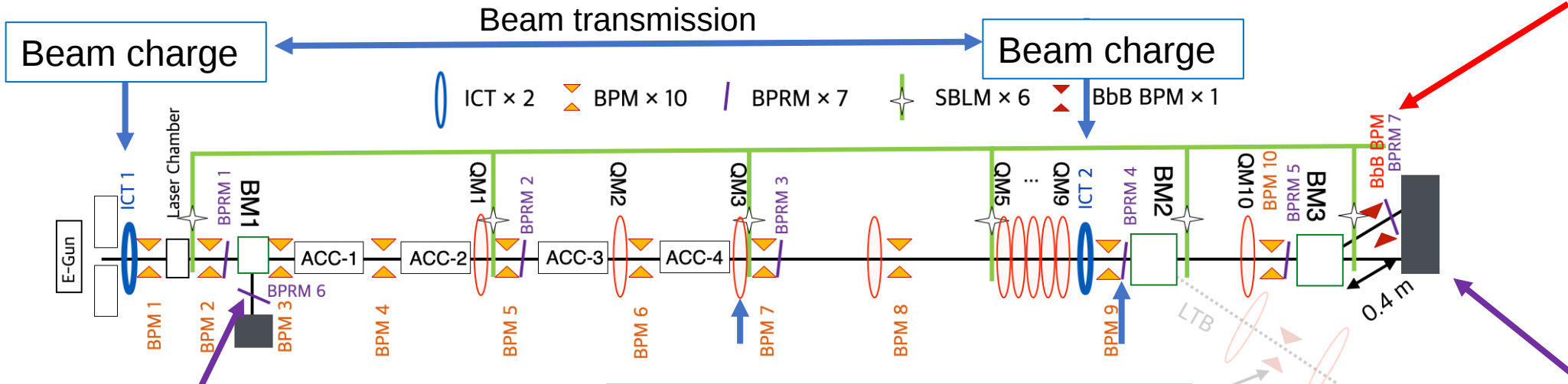
Beam Loss Monitor



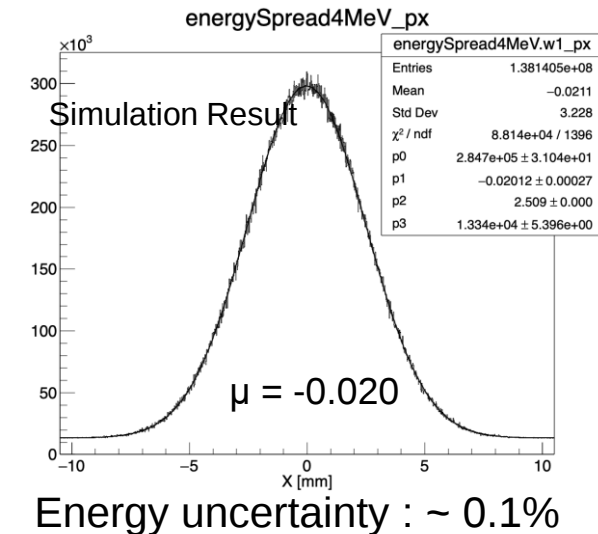
- CMOS-Based Beam loss Monitor
 - Scintillator
 - Photon Detector: CMOS Camera
- Maximum Acquisition Rate: 100 Hz

LINAC Beam Parameter Measurements

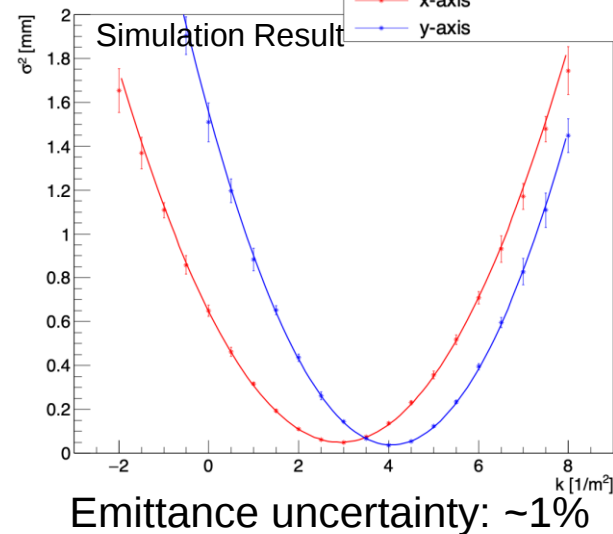
Bunch-by-bunch energy measurement
with GHz BW oscilloscope



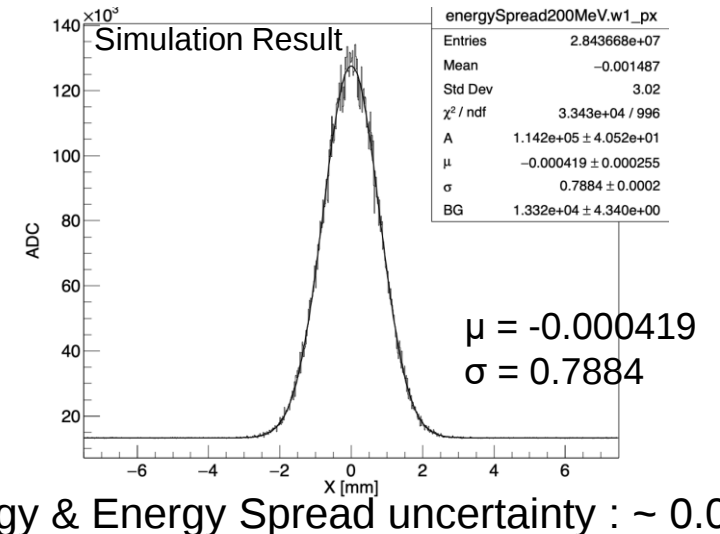
4 MeV energy measurement with BM1 & BPRM 6



Emittance Q-Scan with QM3 & BPRM4

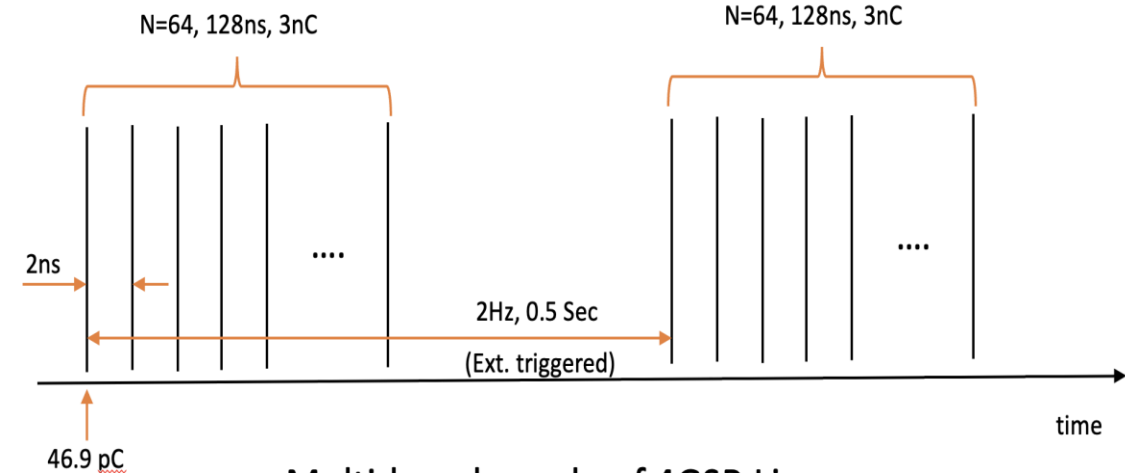


200 MeV energy & energy spread Measurement with BM3 & BPRM 7

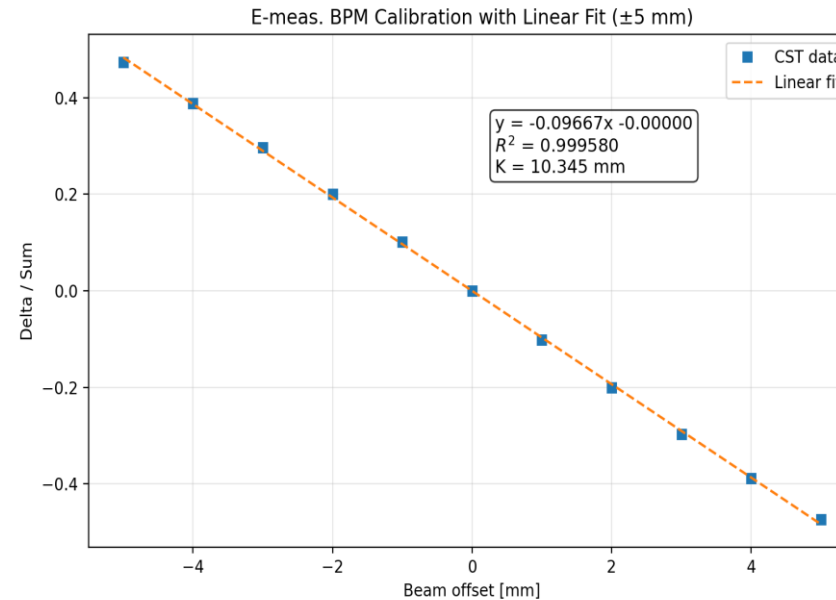
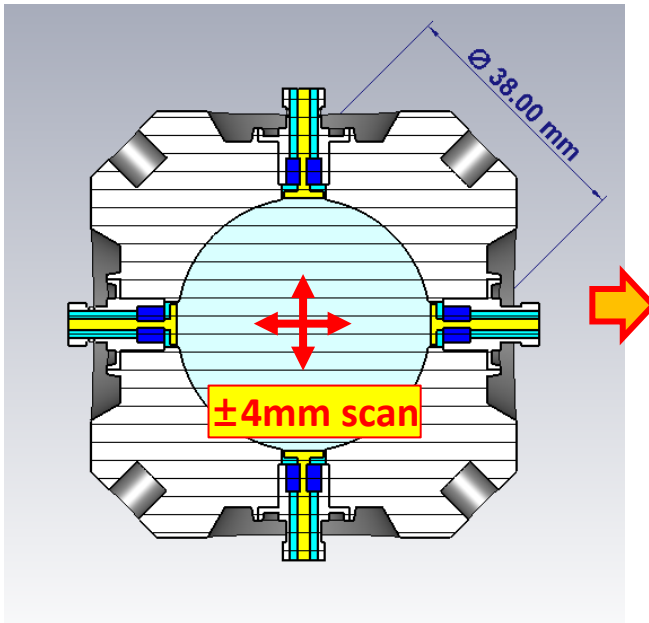


Bunch Resolved Energy Measurement

- **Bunch-by-bunch energy measurement at LTB**
 - BbB analyzing module
 - **BbB BPM sensitivity: $K_x \sim 10 \text{ mm}$**
- **High-speed direct sampling using 50–100 GS/s oscilloscope**
 - **Expected energy resolution: $\sim 0.025\%$ ($\sim 50 \text{ keV}$ @ 200 MeV)**
 - Equivalent BPM position resolution: $\sim 110 \mu\text{m}$ at $D_x \sim 0.45 \text{ m}$
- **E-meas. Resolution requirement for Feedback: $\leq 0.05\%$ ($\sim 100 \text{ keV}$ @ 200 MeV)**
 - Corresponding BPM position change: $\sim 225 \mu\text{m}$
 - Expected measurement resolution is better than the feedback requirement
- **Sufficient for monitoring Linac energy stability**
 - Relative energy spread specification: $\leq 0.5\%$ ($\sim 1 \text{ MeV}$)
 - Pulse-to-pulse energy jitter specification: $\leq 0.2\%$ ($\sim 400 \text{ keV}$)
- **Bunch-resolved energy information will be used for injection energy stabilization feedback**



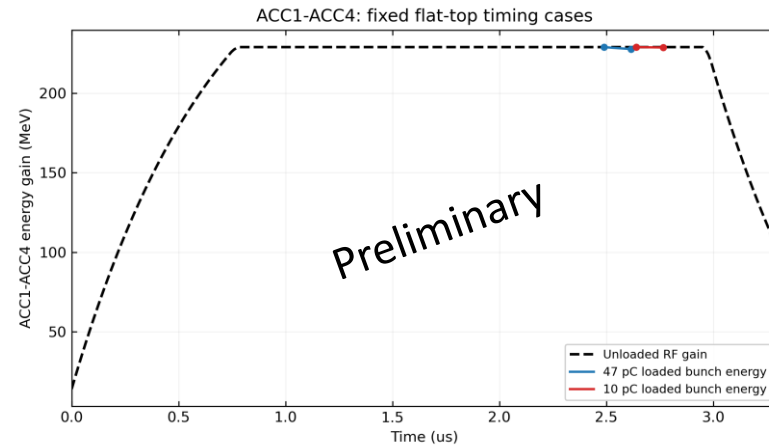
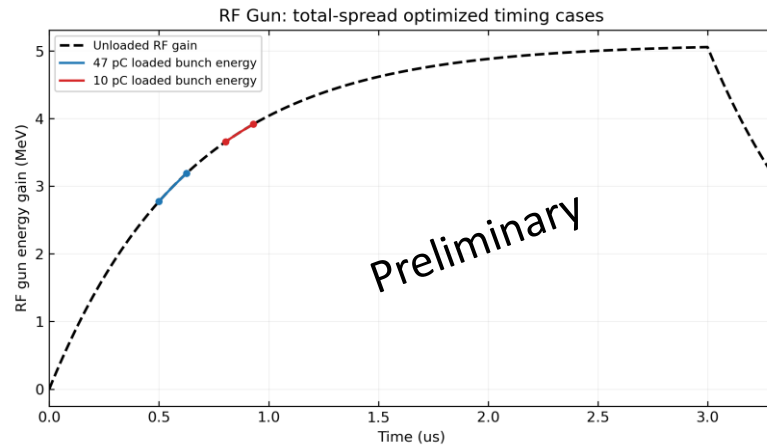
Multi-bunch mode of 4GSR Linac.



Commercial High speed Digitizer
50~100GS/s

Energy control: Beam loading, etc

- Beam loading

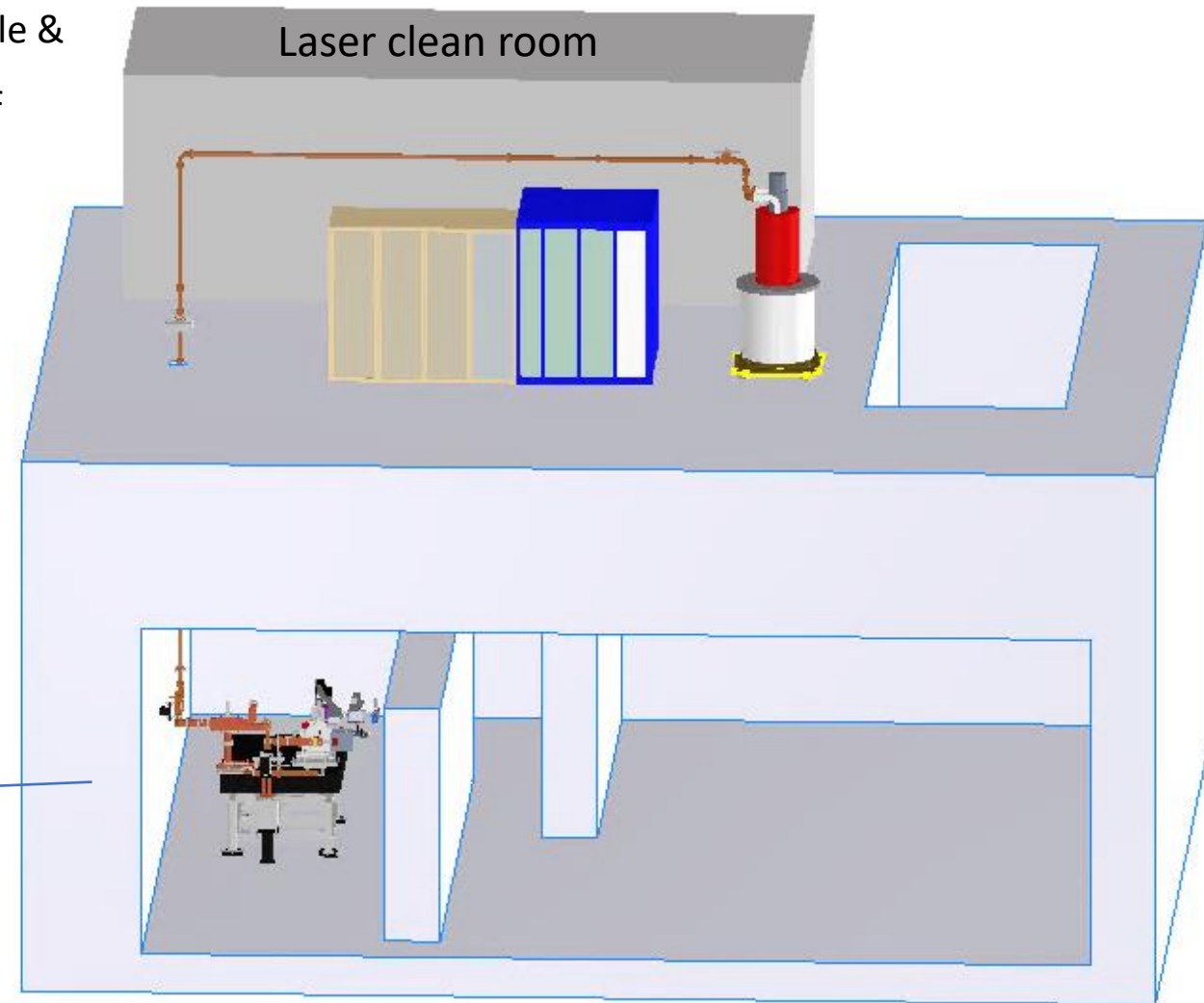
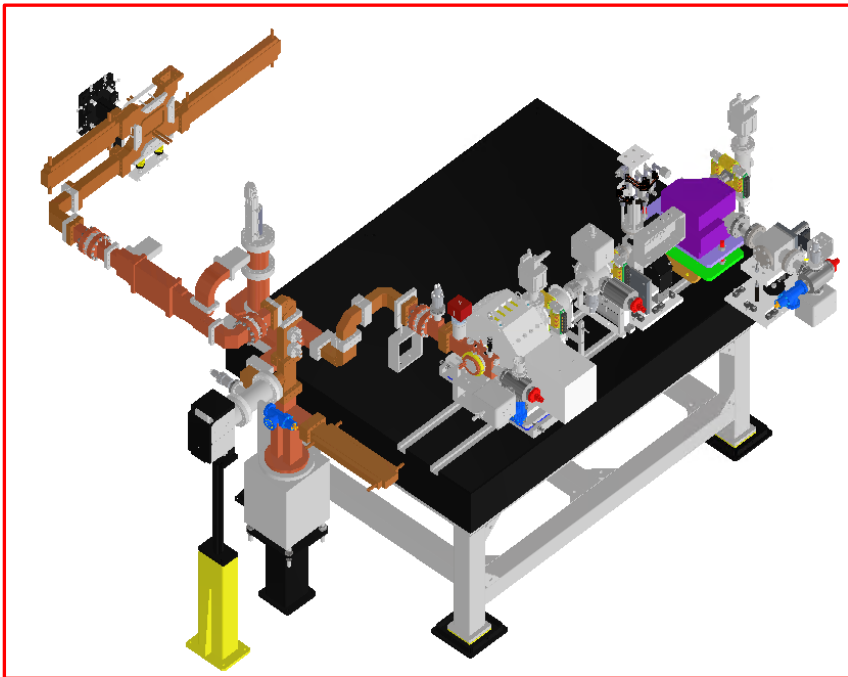


Bunch charge (pC)	Section	Injection time (ns)	Tail-bunch beam-loading loss (MeV)	Bunch-to-bunch RMS energy spread (%)
47, (47x64=3nC)	RF Gun	500.0	0.002190, 0.05%	4.074289
	ACC1-ACC4	2490.0	1.227277, 0.6%	0.156143
	RF Gun + ACC1-ACC4	—	1.229467	0.101497
10, top-up	RF Gun	804.0	0.000466, 0.01%	2.000615
	ACC1-ACC4	2640.0	0.261123, 0.13%	0.033148
	RF Gun + ACC1-ACC4	—	0.261589	0.000341

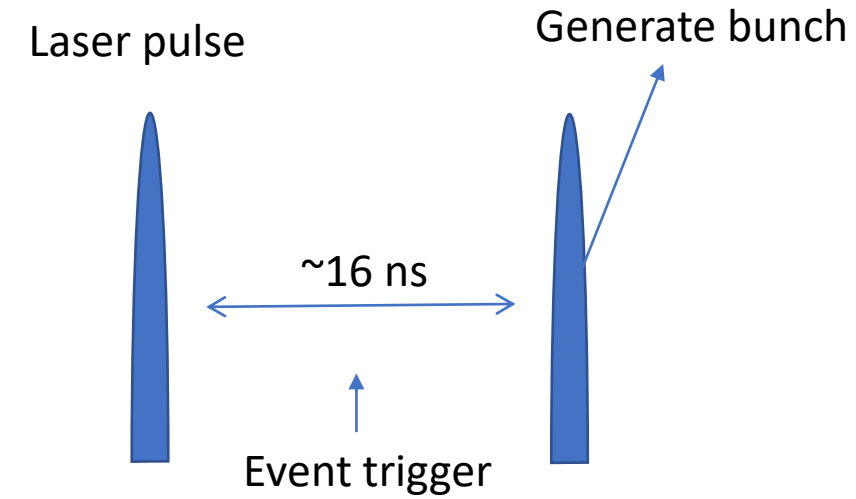
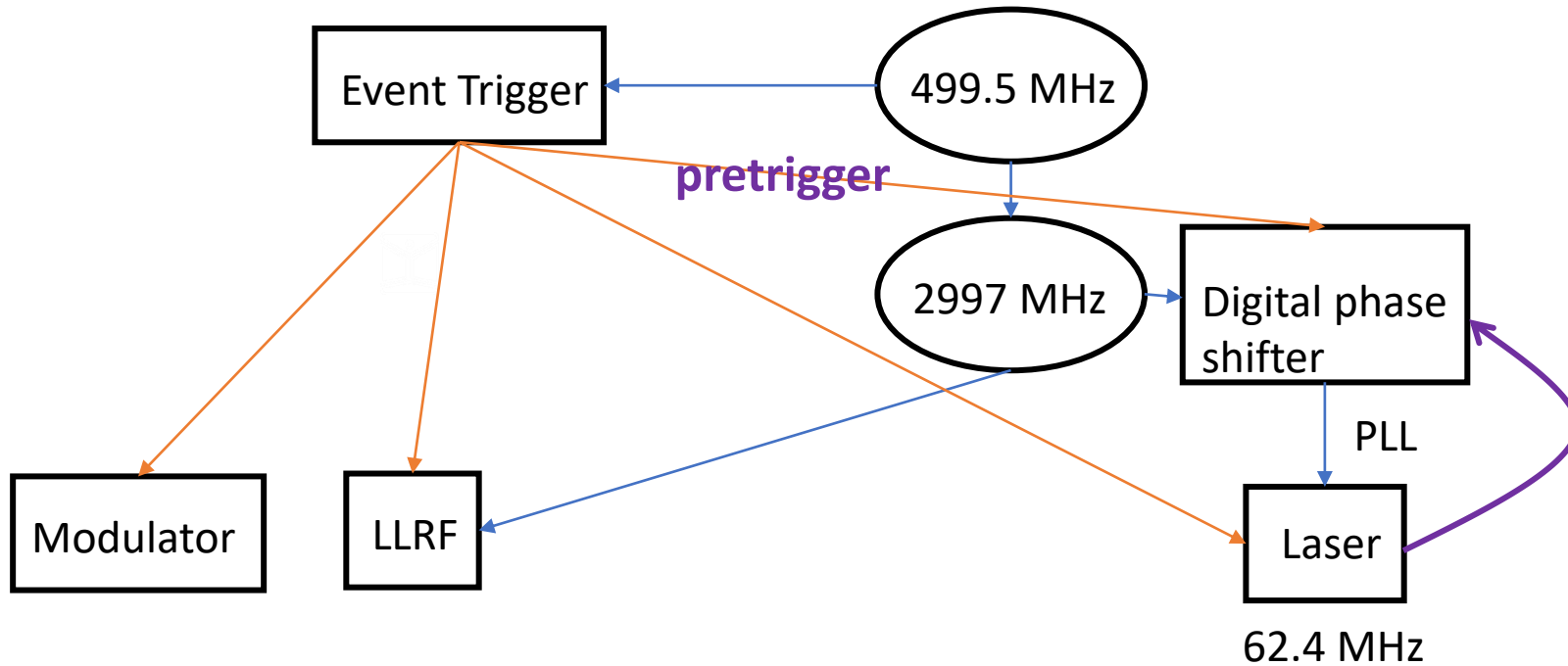
- Energy feedback : LLRF amplitude control with operating 2nd klystron as near saturate regime

Multibunch test at the gun before the installation

- Test 2997.56 MHz photocathode RF gun(QE, dark), injector laser (single & multi), high power phaseshifter, attenuator, klystron, modulator, LLRF
- Test timing control, diagnostics (energy, bunch charge)



Bunch by bunch timing control



- 2 Hz bunch by bunch timing control requested by booster.
- Digital phase shifter scan and position laser pulses to right timing with ~ 0.005 degree (~ 5 fs) resolution.

Summary

- XFEL instruments are further optimized to use in KLS LINAC.
- Photocathode based LINAC provides small beam size and energy spread for the booster injection of KLS
- Passive multipulse laser generation ensures robust operation of multibunch generation.

Milestones

- 2026 : Gun, high power RF components, Klystron, modulator, LLRF, SSA and laser will be procured
- 2028 : Gun test including multi-bunch, gun QE
- 2029 : Installation

Special thanks to

- KLS LINAC advisory committee, Hiroshi Matsumoto (KEK), Takahiro Inagaki (RIKEN SPring-8 Center), John Smedley (SLAC)
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